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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re United States Patent Application of:		Docket No.:	2771-696
Applicants:	HENDRIX, Bryan C., et al.	Conf. No.:	6889
Application No.:	10/803,750	Art Unit:	1762
Date Filed:	March 18, 2004	Examiner:	Kelly M. Stouffer
Title:	CHEMICAL VAPOR DEPOSITION OF HIGH CONDUCTIVITY, ADHERENT THIN FILMS OF RUTHENIUM	Customer No.:	25559

# FACSIMILE TRANSMISSION CERTIFICATE

**ATTN: Examiner Kelly M. Stouffer**

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## Steven J. Hultquist

**June 13, 2007**

Date \_\_\_\_\_

**SUBMISSION OF AMENDMENT UNDER 37 CFR §1.312 IN  
U.S. PATENT APPLICATION NO. 10/803,750**

**Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450**

**Sir:**

**Please amend the claims of the above-identified patent application as set out in Section I**